

Notice of References Cited	Application/Control No. 10/552,382	Applicant(s)/Patent Under Reexamination PRESTWICH ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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NON-PATENT DOCUMENTS

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	U	Yokomatsu et al., caplus an 1996:589339
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